

Docket No.: GR 96 P 8091 P

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By: Mr. P. L.

Date: 6/13/2000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Michael Kelly et al.
Application No. : 09/283,907
Filed : April 1, 1999
Title : Method Of Separating Two Layers Of Material From One Another And Electronic Components Produced Using The Process
Art Unit : 2812

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

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TECHNOLOGY CENTER 2800

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:


C.R. Miskys et al.: "MOCVD-Epitaxy on Free-Standing HVPE-GaN Substrates",
phys. stat. sol. (a) 176, 443 (1999), pp. 443-446;

L. Tsakalakos et al.: "Epitaxial ferroelectric (Pb, La)(Zr, Ti)O₃ thin films on stainless steel by excimer laser liftoff", Applied Physics Letters, Volume 76, Number 2, January 10, 2000, pp. 227-229.

If no translation of pertinent portions of any foreign language patents or publications mentioned above is included with the aforementioned copies of those applications,

patents and or publications, it is because no existing translation is readily available to the applicant.

Respectfully submitted,



For Applicants

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Date: June 13, 2000

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